

Message Text

UNCLASSIFIED

PAGE 01 STATE 042141

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ORIGIN COME-00

INFO OCT-01 EB-07 EUR-12 ISO-00 OES-05 /025 R

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COM/BEWT/TDAD/RFSTECHSCHULTE

COM/BEWT/EE/JTREICHEL

COM/BEWT/USSR/HWHEISS

EUR/EE/RCHRISTENSEN

EUR/EE/DMILLER

EB/EWT/JBEMIS

EUR/SOV/JCOLBERT

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R 251857Z FEB 75

FM SECSTATE WASHDC

TO AMEMBASSY BUDAPEST

AMEMBASSY BUCHAREST

AMEMBASSY MOSCOW

AMEMBASSY PRAGUE

AMEMBASSY WARSAW

UNCLAS STATE 042141

E.O. 11652: N/A

TAGS: BEXP, XG

SUBJECT: TRADE OPPORTUNITIES - PRODUCTION EQUIPMENT FOR
SILICON WAFERS

1. KAYEX CORP. INTERESTED IN SELLING EQUIPMENT USED TO
MANUFACTURE SILICON CRYSTALS FOR WAFERS FOR INTEGRATED
CIRCUITS, TRANSISTORS, SEMICONDUCTORS. THE SYSTEM IS
ESSENTIALLY THE FIRST STAGE IN A PRODUCTION LINE FOR THE
MANUFACTURE OF SEMICONDUCTORS, ETC.

2. EQUIPMENT INCLUDES: CRYSTAL GROWING FURNACE,
PRECISION WAFERING MACHINE, WAFER POLISHER, WAFER MOUNTING
STATION, DEWAXER AND SAW BLADES.

3. ANY INFO OR SPECIFIC TRADE OPPORTUNITY WOULD BE
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APPRECIATED. KISSINGER

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01 JAN 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: n/a
Control Number: n/a
Copy: SINGLE
Draft Date: 25 FEB 1975
Decaption Date: 01 JAN 1960
Decaption Note:
Disposition Action: n/a
Disposition Approved on Date:
Disposition Authority: n/a
Disposition Case Number: n/a
Disposition Comment:
Disposition Date: 01 JAN 1960
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1975STATE042141
Document Source: CORE
Document Unique ID: 00
Drafter: SASIND:VAS
Enclosure: n/a
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Errors: N/A
Film Number: D750067-0608
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1975/newtext/t19750214/aaaaamgk.tel
Line Count: 61
Locator: TEXT ON-LINE, ON MICROFILM
Office: ORIGIN COME
Original Classification: UNCLASSIFIED
Original Handling Restrictions: n/a
Original Previous Classification: n/a
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Previous Classification: n/a
Previous Handling Restrictions: n/a
Reference: n/a
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Review Authority: ElyME
Review Comment: n/a
Review Content Flags:
Review Date: 16 MAY 2003
Review Event:
Review Exemptions: n/a
Review History: RELEASED <16 MAY 2003 by SilvaL0>; APPROVED <08 JAN 2004 by ElyME>
Review Markings:

Margaret P. Grafeld
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Review Media Identifier:
Review Referrals: n/a
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Review Withdrawn Fields: n/a
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Status: NATIVE
Subject: TRADE OPPORTUNITIES - PRODUCTION EQUIPMENT FOR SILICON WAFERS
TAGS: BEXP, XG
To: BUDAPEST MULTIPLE
Type: TE
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